

(Use several sheets if necessary)

Docket Number (Optional)

TSMC-97-542/98-021

Application Number

09/160,965

**Applicant**

Applicant S.L. Shve et al

Filing Date

Filing Date 09/25/98

Group Art Unit

Group Art Unit 2812

## U. S. PATENT DOCUMENTS

U. S. PATENT DOCUMENTS												
EXAMINER INITIAL	DOCUMENT NUMBER						DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
EL	4	9	5	4	4	5	9/4/90	Aranzho et al	437	228	7/3/89	
EL	4	7	8	9	6	4	8/12/61	Chow et al	437	225	10/28/85	
EL	4	7	6	2	7	9	2/10/67	Chow et al	156	628	10/28/85	
EK	5	6	9	3	5	6	3/12/21	Teong	437	190	7/15/96	
EK	5	5	6	7	3	0	0/10/22	Datta et al	205	652	9/2/94	
EK	5	3	4	6	5	8	4/9/13	Nasr et al	156	636	7/28/93	
EK	5	4	9	4	8	5	7/2/27	Cooperman et al	437	228	7/28/93	
EK	5	6	0	2	4	2	3/2/11	Jain	257	752	6/7/95	

**RECEIVED**

NOV 23 1994

**FOREIGN PATENT DOCUMENTS**

~~GROUP 2100~~

[illegible]

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
OK		C.Y. Chang et al, "ULSI Technology" The McGraw-Hill Companies, Inc, New York, 1996, p 447

**EXAMINER**

Erh. Kaelin

DATE CONSIDERED

13 Jan 2000

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.